



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 9239

SERIAL NUMBER 10/717,552	FILING OR 371(c) DATE 11/21/2003 RULE	CLASS 356	GROUP ART UNIT 2877	ATTORNEY DOCKET NO. 245651US2
------------------------------------	---	---------------------	-------------------------------	---

APPLICANTS

Yoshio Takami, Yokohama-shi, JAPAN;

**** CONTINUING DATA *******I.A.
None**** FOREIGN APPLICATIONS *******

JAPAN 2002-341330 11/25/2002

I.A.
None**IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****

02/24/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 50	INDEPENDENT CLAIMS 11
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <u><i>[Signature]</i></u> Examiner's Signature <u><i>I.A.</i></u> Initials				

ADDRESS

22850

TITLE

Method and apparatus for forming substrate for semiconductor or the like

FILING FEE RECEIVED 1998	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit